



PATENT  
Atty. Dkt. AMAT/5908.Y1/CPI/ALUMINUM/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Wang, et al.

Serial No.: 10/046,954

Filed: January 14, 2002

Confirmation No.: 4418

**For:** Semiconductor Wafer Preheating

MAIL STOP RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2125

**Examiner:** Kidest Bahta

CERTIFICATE UNDER 37 CFR 1.10

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on 4/14, 2005 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV321685281US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

4/14/05

Kid n zahr

## **PRELIMINARY AMENDMENT**

In response to the Final Office Action dated December 14, 2004, having a shortened statutory period for response extended one month to and including April 14, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5908.Y1/KMT for any fees required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.